

Notice of References Cited	Application/Control No. 10/749,448	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Hai L. Nguyen	Art Unit 2816	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,834,183	12-2004	Black et al.	455/182.1
*	B	US-6,774,679	08-2004	Nogami, Kazutaka	327/3
*	C	US-6,628,154	09-2003	Fiscus, Timothy E.	327/158
*	D	US-6,392,456	05-2002	Pyeon et al.	327/156
*	E	US-6,275,079	08-2001	Park, Boo Young	327/143
*	F	US-6,211,747	04-2001	Trichet et al.	332/128
*	G	US-6,154,073	11-2000	Choi, Jae Myoung	327/161
*	H	US-5,926,515	07-1999	Park, Jae-Sun	375/376
*	I	US-5,389,899	02-1995	Yahagi et al.	331/10
*	J	US-5,355,098	10-1994	Iwasaki, Keiichi	331/14
*	K	US-4,803,705	02-1989	Gillingham et al.	375/375
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.